JUN 3 0 2003 F

In re application of:

Jammy et al.

Serial No.:

09/363,523

Group: Art Unit 2823

Filed:

July 29, 1999

Examiner: Estrada, Michelle

For:

METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

Mail Stop Non-Fee Amendment Commissioner for Patents

PO Box 1450

Alexandria VA 22313-1450

## AMENDMENT TRANSMITTAL FORM

Sir:

Transmitted herewith is an amendment in the above-identified application.

[ ] Small entity status of this application under 37 C.F.R. § 1.9 and 1.27 has been established by a verified statement previously submitted.

A verified statement to establish small entity under 37 C.F.R. § 1.9 and 1.27 is enclosed.

[X] No additional fee is required.

The fee has been calculated as shown below:

OTHER THAN
Y SMALL ENTITY

SMALL ENTITY (Col. 1) (Col. 2) (Col. 3) **CLAIMS** REMAINING HIGHEST NO. ADDIT. ADDIT. **PRESENT PREVIOUSLY** AFTER **FEE FEE** OR **RATE** PAID FOR **EXTRA** RATE **AMENDMENT** \$0 0 X 18 **MINUS** 20\*\* = 0X 9 **TOTAL** 20 \* 3\*\*\* X 84 \$0 INDEP. **MINUS** = 0X 42 S 0 3\* ] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM X 280 \$0 Х 140 \$ OR TOTAL \$0 TOTAL

ADDIT. FEE \$ 0

\*If the entry in Co. 1 is less than entry in Col. 2, write "0" in Col. 3.

\*\* If the "Highest No. Previously Paid for" IN THIS SPACE is less than 20, enter "20".

\*\*\* If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The Highest No. Previously Paid For" (Total or indep.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

[ ] Please charge Deposit Account No. \_\_\_ in the amount of \$\_\_. Two (2) copies of this sheet are enclosed.

Please charge fee of \$\_\_\_ for \_\_\_\_\_ by Credit Card Payment Form PTO-2038 enclosed herewith

[X] Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. § 1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. 50-0679. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. 50-0679 therefor. TWO (2) COPIES OF

THIS SHEET ARE ENCLOSED.

F. CHAU & ASSOCIATES 1900 Hempstead Turnpike Suite 501 East Meadow, NY 11554

Tel: (516) 357-0091 Fax: (516) 357-0092 Respectfully submitted,

Frank V. DeRosa Reg. No. 43,584

Attorney for Applicant

### CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop Non-Fee Amendment, Commissioner for Patents, PO Box 1450, Alexandria VA 22313-1450 on <u>June 27, 2003</u>.

Dated: 6/27/03

Frank V. DeRosa





# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jammy et al.

Examiner: Estrada, Michelle

Serial No: 09/363,523

Group Art Unit: 2823

Filed: July 29, 1999

Docket: 99-P-7722-US (8055-98)

For: METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

Mail Stop: Non-Fee Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## **RESPONSE**

This is a response to the Office Action mailed on March 27, 2003. Please consider the following remarks to the above-identified application as follows:

### CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Mail Stop: Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on June 27, 2003.

Dated: 6/27/0

Frank V. DeRosa